

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	MAIL STOP IDS
Nathan S. Lewis et al.)	Group Art Unit: 2813
Patent No.: 7,491,642)	Examiner: COLLEEN E. SNOW
Issued: February 17, 2009)	Confirmation No.: 2732
For: ELECTRICAL PASSIVATION OF)	Certificate of Electronic Deposit
SILICON-CONTAINING SURFACES)	
USING ORGANIC LAYERS)	I hereby certify that this correspondence is being
)	deposited with the United States Patent & Trademark
)	Office on June 5, 2009 via EFS-Web.
)	By: <u>/Joseph R. Baker, Jr./</u>
)	Joseph R. Baker, Jr.

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is an Information Disclosure Statement for the above-identified patent application. This Information Disclosure Statement is being filed within three (3) months of receipt of Foreign Communication. No fee is believed to be due.

- ☒ Also enclosed is/are: Form SB08a, Foreign Reference - 1, Non-patent Literature – 1
- ☒ Small entity status is hereby claimed.
- ☐ A check in the amount of _____ is enclosed for the fee due.
- ☐ Charge _____ to credit card for the fee due.
- ☒ The Director is authorized to charge any required fee or credit any overpayment to Deposit Account Number 50-4586, please reference the attorney docket number above.

Respectfully submitted,

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Date June 5, 2009

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